

**LASER PEENING METHOD**

Patent Number: JP7246483  
Publication date: 1995-09-26  
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Applicant(s): TOSHIBA CORP  
Requested Patent: ☐ JP7246483  
Application Number: JP19940038662 19940309  
Priority Number(s):  
IPC Classification: B23K26/00; B23K26/12; B23K26/18; C21D7/06  
EC Classification:  
Equivalents: JP3373638B2

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**Abstract**

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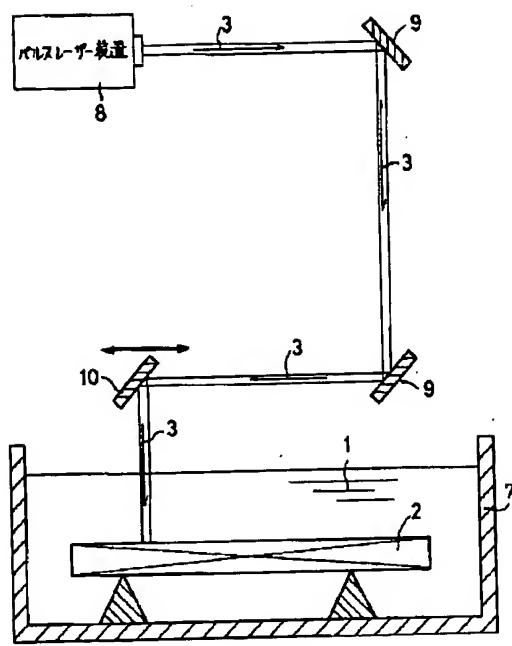
**PURPOSE:** To execute stress condition change of the metal surface not requiring reaction force compensation so as to increase working efficiency and improve reliability.

**CONSTITUTION:** The surface of a work 2 is irradiated with a laser beam 3 from a pulse laser device 8 through a reflection mirror 9 and traveling reflection mirror 10. The work 2 is placed in a transparent liquid 1, with the traveling reflection mirror 10, by irradiating the laser beam 3 while changing an irradiating position on the surface of the work 2, compression stress is made remained on the surface of the material 2 to be worked.

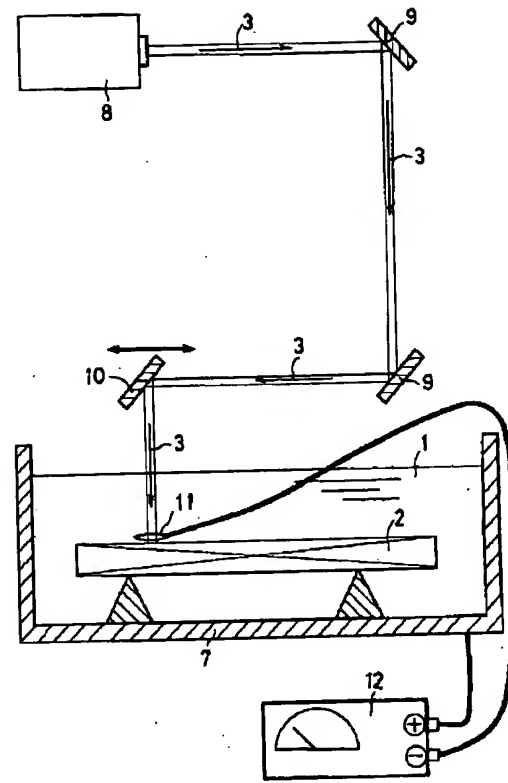
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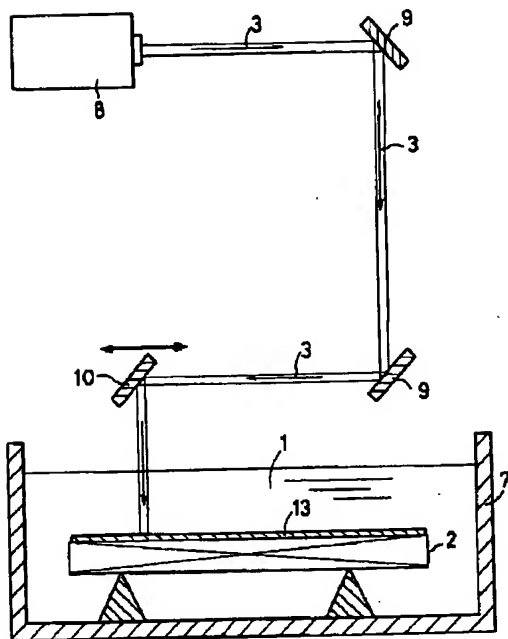
【図1】



【図2】



【図3】



【図4】

